

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,915,906 B2  
DATED : July 12, 2005  
INVENTOR(S) : James D. Pylant et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 5,

Line 8, replace "a wafer storage chamber for storing a stack of wafer elements," with -- a wafer storage chamber having a specific height for storing a stack of wafer elements --.

Column 6,

Line 2, replace "adapted the stack" with -- adapted to surround the stack --.  
Line 23, replace "assist" with -- assists --.

Signed and Sealed this

Sixteenth Day of May, 2006

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a cursive "Dudas".

JON W. DUDAS  
*Director of the United States Patent and Trademark Office*